

FORM PTO-1449 U.S. DEPARTMENT OF COMMERCE (MODIFIED) PATENT AND TRADEMARK OFFICE INFORMATION DISCLOSURE STATEMENT BY APPLICANT (37 CFR 1.98(b))	ATTY. DOCKET NO. PSU Docket No. 97-1804	SER. NO. Not Yet Assigned
	APPLICANT RANDALL, Dr. Clive A, and Jonathan Van Tassel	
	FILING DATE	GROUP

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Examiner Initial	Cite No. ¹	Patent Number	Issue Date	Patentee	Class/ Subclass	Filing Date
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FOREIGN PATENT OR PUBLISHED FOREIGN PATENT APPLICATION

Examiner Initial	Document Number	Publication Date	Country or Patent Office	Class/ Subclass	Translation Yes/No

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		M.S.J. Gani, ELECTROPHORETIC DEPOSITION - A REVIEW, Industrial Ceramics Volume 14 N.4, 1994, pp. 163-174.
<i>W</i>		Sarkar, Partho, et al., ELECTROPHORETIC DEPOSITION (EPD): MECHANISMS, KINETICS, AND APPLICATION TO CERAMICS, Journal of the American Ceramic Society, Vol. 79, No. 8, 1996, pp. 1987-2002.

EXAMINER	DATE CONSIDERED
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EXAMINER: Initial citation considered. Draw line through citation if not in conformance and not considere
 Include copy of this form with next communication to applicant.